

Electronic Acknowledgement Receipt

EFS ID:	1267352
Application Number:	10697676
International Application Number:	
Confirmation Number:	8382
Title of Invention:	CHEMICAL MECHANICAL POLISHING METHOD AND APPARATUS
First Named Inventor/Applicant Name:	Joe G. Tran
Customer Number:	23494
Filer:	Yingsheng Tung/Jackie McBride
Filer Authorized By:	Yingsheng Tung
Attorney Docket Number:	TI-37297
Receipt Date:	23-OCT-2006
Filing Date:	30-OCT-2003
Time Stamp:	13:27:34
Application Type:	Utility

Payment information:

Submitted with Payment	no
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Drawings	TI-37297_DRAWINGS.pdf	331380	no	2

Warnings:

Information:	Total Files Size (in bytes):	331380
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If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.		
<u>National Stage of an International Application under 35 U.S.C. 371</u>		
If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.		